Application Number:	105	10534687					
Filing Date:	31-	31-Jan-2006					
Title of Invention:	AT	ATOMIC LAYER DEPOSITION USING METAL AMIDINATES					
First Named Inventor/Applicant Name:	Roy	Roy G Gordon					
Filer:	Yui	Yunghoon Ha					
Attorney Docket Number:	426	42697.149 US3					
Filed as Large Entity	•						
U.S. National Stage under 35 USC 371 F	iling Fee	3					
Description		Fee Code	Quantity	Amount	Sub-Total ir USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
			-				

Publ. Fee- early, voluntary, or normal

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Printed copy of patent - no color	8001	4	3	12
	Tot	1822		